

# LIST OF ART CITED BY APPLICANT

## (PTO-1449)

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**Choong-Jae LEE**

 FILING DATE  
**December 12, 2003**

 GROUP  
**2618**

### U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE
	<b>6,064,453</b>	<b>05/16/2000</b>	<b>Inubushi et al.</b>	<b>349</b>	<b>58</b>	<b>08/06/1998</b>
	<b>6,229,994</b>	<b>05/08/2001</b>	<b>Pavet</b>	<b>455</b>	<b>90</b>	<b>02/04/1999</b>

### U.S. PATENT APPLICATION PUBLICATIONS

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	

### U.S. PATENT APPLICATIONS

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	

### FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	<b>CN 1233126</b>	<b>10/27/1999</b>	<b>China (English Abstract &amp; Full Chinese Text)</b>			<b>X</b>	

### OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)

	<b>Chinese Office Action dated June 1, 2007</b>

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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